EXPRESS MAIL NO. EV33665 L015 U

**PATENT** 



**Applicants** 

Reishi Naka et al.

Application No.

APR 0 2 20C4

10/004,538

Filed

October 23, 2001

For

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THERMAL CONDUCTIVITY MEASUREMENT METHOD AND

INSTRUMENT AND METHOD OF PRODUCING A HEAT

INSULATING MATERIAL

Examiner

Gail Kaplan Verbitsky

Art Unit

2859

Docket No.

980039.409

Date

April 2, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE**

## Commissioner for Patents:

In response to the Office Action dated December 4, 2003, please extend the period of time for response one month, to expire on April 4, 2004. Enclosed are a Petition for an Extension of Time and the requisite fee.

Remarks/Arguments begin on page 2 of this paper.